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Atty. Dkt. No. 039153-0310 (F0797)

2812  
#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Calvin T. Gabriel et al.  
Title: PROCESS FOR IMPROVING THE  
ETCH STABILITY OF ULTRA-  
THIN PHOTORESIST  
Appl. No.: 09/819,552  
Filing Date: 03/28/2001  
Examiner: To be assigned  
Art Unit: 2812

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below.	
Roberta Cooper	(Printed Name)
Roberta Cooper	(Signature)
3/6/02	(Date of Deposit)

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REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST

35 U.S.C. 122(b)(2)(B)(ii)

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicants hereby rescind the previous request that the above-identified application not be published under 35 U.S.C. 122(b).

Respectfully submitted,

Date

3-6-02

By

Joseph N. Ziebert

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